

<b>Notice of References Cited</b>	Application/Control No. 10/796,421	Applicant(s)/Patent Under Reexamination LANDSBERGER ET AL.	
	Examiner Paul D. Kim	Art Unit 3729	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,587,097	12-1996	Sato et al.	219/543
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N	JP 03261564 A	11-1991	Japan	ARISAWA, HIROSHI	
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	S					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	"Pulse current trimming of polysilicon resistors"; Feldbaumer, D.W.; Babcock, J.A.; Mercier, V.M.; Chun, C.K.Y.; Electron Devices, IEEE Transactions on Volume 42, Issue 4, April 1995; Pages:689 - 696.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.